


MMS2019 - Delegate Member Biography Form of Japan

First Name	Munehisa	Last Name	Takeda
Title/Position	General Manager of MEMS System Development Center	Affiliation	Micromachine Center
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Biography	Photo
<p>Munehisa Takeda was born in Japan in 1957. He received the B.E. and M.E. degrees in Precision Mechanics at Kyoto University in 1979 and 1981, respectively. He also received M.S degree in Bioengineering at UCSF/UCB in 1988. He joined Mitsubishi Electric Corporation in 1981. After having held general managers of MEMS related departments at Mitsubishi Electric Corporation, he is currently the General Manager of MEMS System Development Center at Micromachine Center. He promoted several Japanese national projects related MEMS technologies such as Micromachine project and Road infrastructure monitoring system development project. His current research interests are robotics, learning control, bioengineering, VR, micromachine, MEMS, and IoT.</p>	
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